YN THE UNITED STATES PATENT AND TRADEMARK OFFICE PATENT TRANSMITTAL FORM

Applicant(s)	a): SEP	12	2005	٢
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Serial No.:	41	RADE	Mir	

DINGER et al.

10/779,516

Filed:

February 13, 2004

For:

SUBSTRATE MATERIAL FOR X-RAY OPTICAL COMPONENTS

Art Unit:

2878

Examiner:

Not Yet Assigned

Confirmation No.:

8909

Customer No.:

27623

Attorney Docket No.: 637.0033USX

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

We are enclosing:

- 1. Supplemental Information Disclosure Statement with copies of references;
- 2. PTO Form 1449;
- 3. Transmittal letter in duplicate; and
- Postcard.

Please charge any additional fees or credit any such fees, if necessary to Deposit Account No. 01-0467 in the name of Ohlandt, Greeley, Ruggiero & Perle. A duplicate copy of this sheet is attached.

Date: September 9, 2005

John Yankovich

Reg. No. 42,240

Ohlandt, Greeley, Ruggiero & Perle, L.L.P.

One Landmark Square, 10th Floor Stamford, Connecticut 06901-2682

(203) 327-4500

CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE U.S. POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO: MAIL STOP AMENDMENT, COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450, , ON September 9, 2005.

Michelle M Bombino
NAME

SIGNATURE

9/9/05

DATE



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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment **Commissioner for Patents** P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with applicants' duty of disclosure under 37 C.F.R. §1.56, we are enclosing form PTO-1449 listing information that may be material to the patentability of this application.

37 C.F.R. 1.98 does not require a copy of U.S. patents or published U.S. patent applications to be included with an information disclosure statement. Accordingly, Applicant is not including a copy of any U.S. patent or published U.S. patent application.

We are also enclosing copies of the non-US references listed on the attached PTO-1449.

been deemed to be pertinent to the claimed present invention. In concluding what was pertinent, the criteria employed was considered most appropriate in light of the invention shown in the present application. However, the Examiner or others may deem some other criteria to be just as appropriate or more appropriate. Therefore, the Examiner is respectfully urged to review the listed citations and to make the usual careful independent search for other prior art that may be pertinent.

Since this Information Disclosure Statement is being filed prior to the issuance of the first Office Action based on the merits, no petition or fee is required.

Applicant respectfully requests favorable consideration and that this application

be passed to allowance.

Respectfully submitted

John Yankovich Reg. No. #2,240

Attorney for Applicant(s)

Ohlandt, Greeley, Ruggiero & Perle, L.L.P.

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Sheet __1_ of __1_. CUSTOMER NO.: 27623 Application Number Docket Number (Optional) FORM PTO-1449 10/779,516 637.0033USX INFORMATION DISCLOSURE CITATI Applicant IN AN APPLICATION AND DINGER et al. Group Art Unit Filing Date (Use several sheets if necessary) 2878 February 13, 2004 U. S. PATENT DOCUMENTS FILING DATE IF **EXAMINER APPROPRIATE CLASS SUBCLASS** NAME **DOCUMENT** DATE INITIAL NUMBER FOREIGN PATENT DOCUMENTS Translation YES NO SUBCLASS CLASS COUNTRY DATE DOCUMENT NUMBER XXX 12/12/02 | WIPO WO02099818 OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.) Allen et al. "An Ion Figuring System for Large Optic Fabrication", SPIE Vol. 1168 Current Developments in Optical Engineering and Commercial Optics (1989), pp. 33-50. Allen et al. "Demonstration of an Ion Figuring Process", SPIE Vol. 1333 Advanced Optical Manufacturing and Testing (1990), pp. 22-33 Wilson et al. "Surface Figuring Using Neutral Ion Beams", SPIE Vol. 966 Advances in Fabrication and Metrology for Optics and Large Optics (1988), pp. 74-80. DATE CONSIDERED **EXAMINER** EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.